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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Brian Vialpando, et al.

Docket No: TI-35829

Serial No: 10/727,392

Conf. No: 7423

Examiner: Karl D. Easthom

Art Unit: 2832

Filed: 12/04/2003

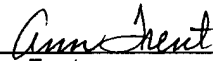
For: THIN FILM RESISTOR STRUCTURE AND METHOD OF FABRICATING A THIN FILM
RESISTOR STRUCTURE

ELECTION

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 4-8-05.

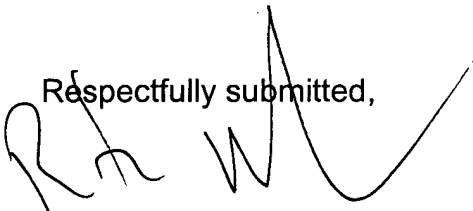

Ann Trent

Dear Sir:

This election is offered in response to the Examiner's restriction requirement mailed March 17, 2005.

Applicants hereby elect to pursue Group II of Claims 10-21, drawn to method of making a resistor, without traversing the Examiner's restriction requirement.

Respectfully submitted,



Peter K. McLarty
Attorney for Applicants
Reg. No. 44,923

Texas Instruments Incorporated
P.O. Box 655474, MS 3999
Dallas, TX 75265
(972) 917-4258